



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81941

Kenji ITO, et al.

Appln. No.: 10/500,253

Group Art Unit: 1725

Confirmation No.: 8926

Examiner: Maria Alexandra ELVE

Filed: June 25, 2004

For: LASER MATERIAL PROCESSING METHOD

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month(s), extending the time for responding to the Office Action of March 27, 2006 to June 27, 2006.

Please charge the statutory fee of \$120.00 to Deposit Account No. 19-4880. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

*Diallo T. Crenshaw*  
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Date: July 27, 2006